



PATENT  
Attorney Docket No. 2013P107

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Seong Deok Ahn et al.

Application No.: 10/672,013

Filed: September 26, 2003

For: **Method and Apparatus Using Large-Area  
Organic Vapor Deposition for Formation of  
Organic Thin Films or Organic Devices**

Examiner: Richard R. Bueker

Art Unit: 1763

Confirmation No.: 7684

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

In response to the Office Action mailed December 1, 2006, in connection with the above referenced patent application, Applicants respectfully request entry of the following amendments and request reconsideration in view of the following remarks.